

Case Docket No. ASMJP.135AUS

Date: March 2, 2006



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Kamal Kishore GOUNDAR
 Appl. No. : 10/616,163
 Filed : July 9, 2003
 For : METHOD OF FORMING
SILICON CARBIDE FILMS
 Group Art Unit : 2813
 Class/Sub-Class : 438-624000
 Examiner : Monica D. Harrison

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

March 2, 2006

(Date)

Katsuhiro Arai, Reg. No. 43,315

TRANSMITTAL LETTER

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing is the Issue Fee for the above-identified application:

- (X) Form PTOL-85.
- (X) A check in the amount of \$1,730.00 to cover the issue fee, publication fee, and advanced order of copies is enclosed.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Katsuhiro Arai
 Registration No. 43,315
 Attorney of Record
 Customer No. 20,995
 (949) 760-0404